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Attorney Docket No. UMC-96-279 Client Matter No. 81848.0016

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Regarding U.S. Patent No. 6,117,345 to:

Chih-Chien LIU, et al.

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For: HIGH DENSITY PLASMA CHEMICAL

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Certificate

FEB 0 3 2004

of Correction

CERTIFICATE OF MAILING BY EXPRESS MAIL

ATTENTION: Certificate of Corrections Branch Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The undersigned hereby certifies that the attached

- 1. Request for Certificate of Correction of Patent For Applicant's Mistake Under 37 C.F.R. 1.323;
- 2. Certificate of Correction (2 originals);
- 3. Return Card, and

this Certificate of Mailing by Express Mail relating to the above application, were deposited as "Express Mail", Mailing Label No. EL533429462US with the United States Postal Service, addressed to ATTENTION: Certificate of Corrections Branch Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 22, 2004.

January 22, 2004

January 22, 2004

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